



Docket No.: M4065.0278/P278
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inter Patent Application of:
Kevin L. Beaman, et al.

Application No.: 09/653,281

Group Art Unit: 2815

Filed: August 31, 2000

Examiner: J. Nguyen

For: USE OF ATOMIC OXIDATION FOR
FABRICATING OF OXIDE-NITRIDE-
OXIDE STACK FOR FLASH MEMORY
DEVICES

9/A
RECEIVED
JAN 23 2002
10:28:00 MAIL ROOM

AMENDMENT

Box Non-Fee Amendment
Commissioner for Patents
Washington, DC 20231

Dear Sir:

In response to the Office Action dated November 1, 2001 (Paper No. 7), please
amend the above-identified U.S. Patent application as follows:

In the Claims:

Please rewrite claims 5, 20 and 35 as shown in the Replacement Claims: